



03500.015334.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
: Examiner: Kabari Guharay  
KAZUYA ISHIWATA ET AL. )  
: Group Art Unit: 2879  
Application No.: 09/846,364 )  
: Filed: May 2, 2001 )  
: For: A SUBSTRATE STRUCTURE )  
: WHICH IS A PRECURSOR TO AN )  
: ELECTRON SOURCE, AND )  
: HAVING A SUBSTRATE AND AN )  
: INSULATING MATERIAL LAYER )  
: WITH METAL OXIDE PARTICLES )  
(As Amended) ) March 1, 2004

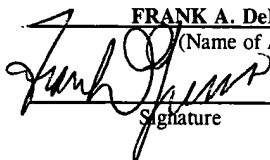
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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

A Request for Continued Examination is being filed herewith. Preliminary  
to continued examination, please amend the above-identified application as follows:

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first-class mail in an envelope  
addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria,  
VA 22313-1450 on March 1, 2004.  
(Date of Deposit)

FRANK A. DeLUCIA (REG. NO. 42,476)  
(Name of Attorney for Applicant)  
 March 1, 2004  
Signature Date of Signature